

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Toru KIMURA <i>et al.</i>	Confirmation No.:	4887
Application No.:	10/586,187	Examiner:	Johnson, Connie P.
Filed:	July 31, 2007	Group Art Unit:	1795

For: **UPPER LAYER FILM FORMING COMPOSITION FOR LIQUID
IMMERSION AND METHOD OF FORMING PHOTORESIST PATTERN**

Commissioner for Patents
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Dear Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated April 19, 2010.

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